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(Rev. 8-88)U.S. Department of Commerce  
Patent and Trademark OfficeAttorney Docket No.  
7648/81349Serial No.  
09/945,530INFORMATION DISCLOSURE STATEMENT  
(Use several sheets if necessary)Applicant(s)  
Rockwell Science CenterFiling Date  
August 3, 2001Group No.  
2122

## U.S. PATENT DOCUMENTS

Examiner Initials	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
ca	5,704,017	12/30/97	Heckerman, et al.			
ca	5,819,258	10/6/98	Vaithyanathan, et al.			
ca	5,832,182	11/3/98	Zhang, et al.			
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## FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)


Examiner

*C. Rodriguez*

Date Considered

09/17/04

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Patent and Trademark OfficeAttorney Docket No.  
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INFORMATION DISCLOSURE STATEMENT  
(Use several sheets if necessary)Applicant(s)  
Kil, et al.Filing Date  
March 4, 2002Group No.  
2171

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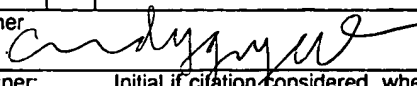
	Document Number	Date	Country	Class	Subclass	Translation	
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INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				Applicant(s) Rockwell Science Center		
				Filing Date March 4, 2002		
				Group No. 2171		
<b>U.S. PATENT DOCUMENTS</b>						
Examiner Initials	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
CN	5,404,513	4/4/95	Powers, et al.			
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<b>FOREIGN PATENT DOCUMENTS</b>						
	Document Number	Date	Country	Class	Subclass	Translation Yes      No
<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)</b>						
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